



Embedded-EEPROM descrambling via laser-based techniques – A case study on AVR MCU

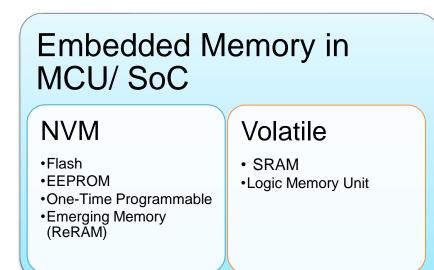
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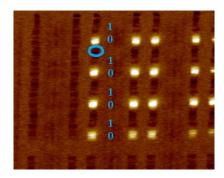
Introduction

- Embedded NVM memories may stores different types of assets:
 - Program/Firmware
 - User's information (e.g. Data, Passwords)
 - Encryption Key
- Constitute a target of choice for:
 - Hardware Security Evaluation
 - Forensic Analysis
- Recovering data from embedded memory:
 - 1. Estimation of bitcell data (i.e. 1 or 0)
 - 2. Understanding of physical implementation of data (i.e. Addressing/Descrambling)

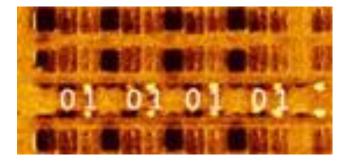




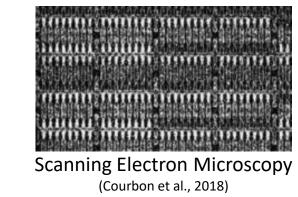
Estimation of bitcells data in Flash/EEPROM



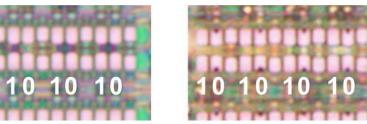
Scanning Capacitance Microscopy (Tay et al., 2019)



Scanning Non-Linear Dielectric Microscopy (Zeng et al., 2021)







Selective Chemical Staining (Zeng et al., 2022)

Motivation for descrambling

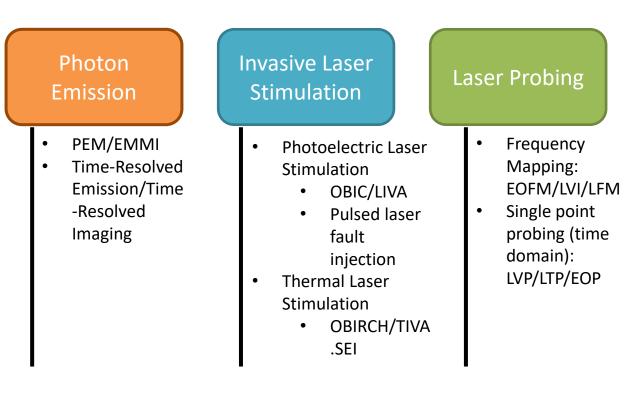
<u>Challenges</u>:

- When studying a new device, results may not be as expected:
 - Different type of transistors?
 - Physics does not apply to this reference?
 - Data not organized as initialy assumed?
- Number of samples to carry out the analysis can be limited
- Data can be scrambled and/or not follow an obvious sequence
- How to verify/understand data location and organization (i.e. descrambling)?



Semi-Invasive Analysis and Optical Techniques

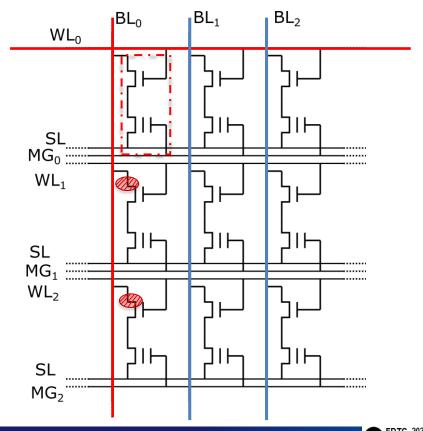
- Enable access to internal signals.
- May assist in:
 - Localization of assets
 - Recovery of assets





Bitline/Column localization: Laser Fault injection

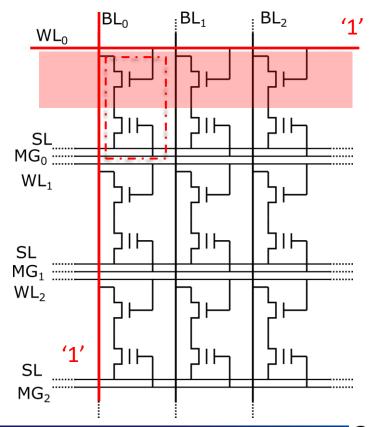
- As reported by several research groups, laser fault can be triggered during read operations in NOR flash.
- Originates from the reversed bias drain/well junction in off-state transistors connected to the read cell bitline.
- Provides the column information.
- Works only one way (e.g. only when the cell being read stores '1').



Fault Diagnosis and Tolerance in Cryptography

Wordline/Row Localization: Laser Probing

- Laser probing consists in monitoring the change of reflectance due to transistors biasing.Of use for:
 - Probing internal signals in ICs.
 - Generate frequency mapping image (i.e. localization of nodes operating at a specific frequency)
- During a read operation, all the transistors connected to the same WL signals are switched on => Can Laser probing help?



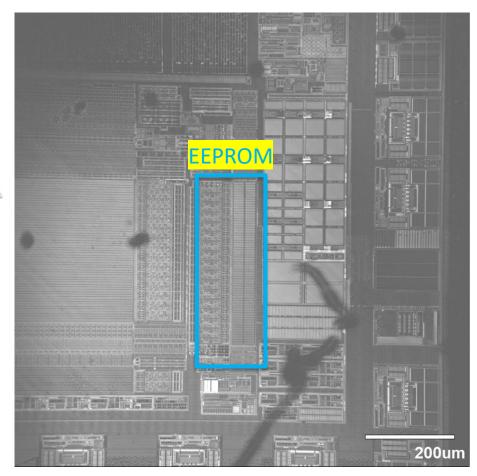


Application: Target

- DUT: AVR ATMega168 PB
 - 8 bits MCU
 - Technology 130 nm
 - 512B EEPROM

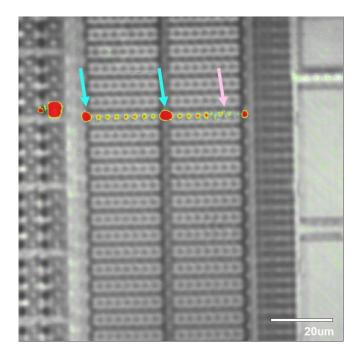


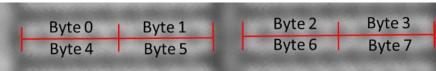


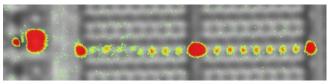




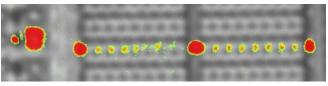
Wordline detection



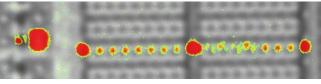




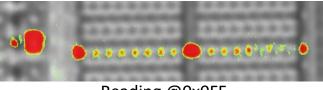
Reading @0x0FC



Reading @0x0FD



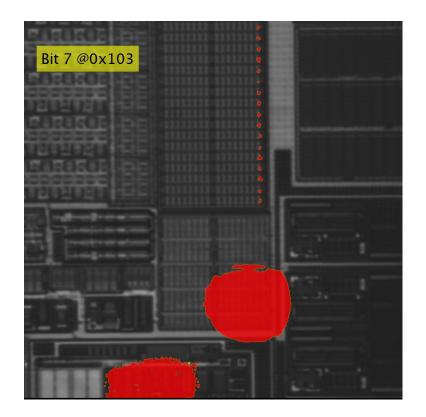
Reading @0x0FE



Reading @0x0FF



Bitline detection

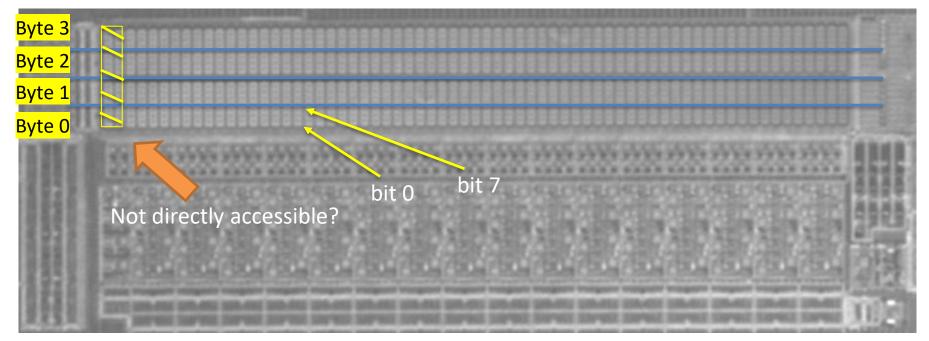


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EEPROM Descrambling



EEPROM @0x000



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Fault Diagnosis and



Summary and Conclusion

- Recovery of data from embedded EEPROM requires ability to estimate cells content and match bitcell location with addresses (descrambling).
- If only a small number of samples is available, methods with limited invasiveness are preferred.
- Discussed a process to recover data organization in embedded EEPROM using laser fault injection (bitline/column) and laser probing (wordline/row).
- Demonstrated proofs of concept in AVR MCU ATMega168 PB.
- Possible application to more advanced MCUs/SoCs
 - Optical resolution challenge => SIL/VLP
 - Device complexity
 - Heterogeneous packaging





J. Y. Tay, J. Cheah, Q. Liu and C. L. Gan, "Study of Front-Side Approach to Retrieve Stored Data in Non-Volatile Memory Devices Using Scanning Capacitance Microscopy," 2019 IEEE 26th International Symposium on Physical and Failure Analysis of Integrated Circuits (IPFA), 2019, pp. 1-4, doi: 10.1109/IPFA47161.2019.8984802.

X. M. Zeng, Q. Liu, J. Y. Tay and C. L. Gan, "Selective Staining on Non-Volatile Memory Cells for Data Retrieval," in *IEEE Transactions on Information Forensics and Security*, vol. 17, pp. 1884-1892, 2022, doi: 10.1109/TIFS.2022.3172222.

X.M. Zeng, Q. Liu, J.Y. Tay, K.Y. Chew, J. Cheah and C.L. Gan, "High resolution front-side visualization of charge stored in EEPROM with scanning nonlinear dielectric microscopy (SNDM)", Nanotechnology, 2021, 32, 485201

F. Courbon, "Challenges and examples of in-situ memory content extraction techniques," 2018 25th IEEE International Conference on Electronics, Circuits and Systems (ICECS), 2018, pp. 493-496, doi: 10.1109/ICECS.2018.8617941.



THANK YOU!

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